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Photon Collider Laser

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Photon Collider Laser



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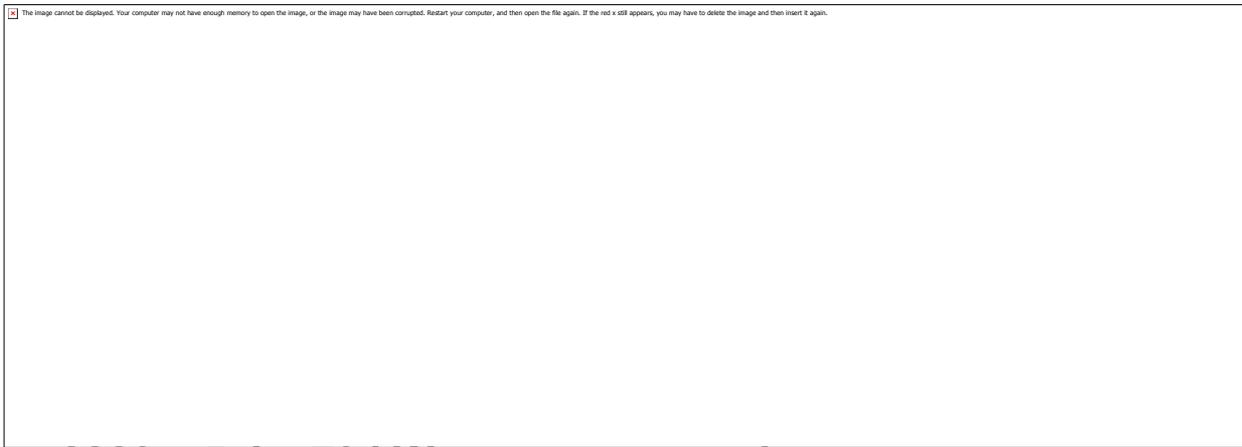
This work performed under the auspices of the U.S.
Department of Energy by Lawrence Livermore National
Laboratory under Contract DE-AC52-07NA27344.

Is it feasible to build the laser?



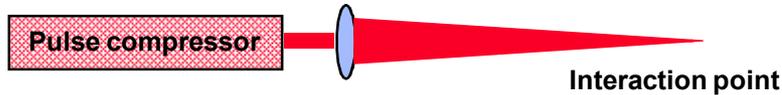
Requirements at interaction point:

- Energy $\sim 5-10$ J
- Spot size $\sim 10-20$ μm (diffraction-limited)
- Wavelength ~ 1 μm
- Pulse length ~ 2.4 ps FWHM ($\sigma = 1$ ps)
- Circular polarization
- Rep rate/pulse train for superconducting L-band accelerator:
 - 369 ns bunch spacing
 - 2820 bunches/train
 - 5 Hz train repetition rate



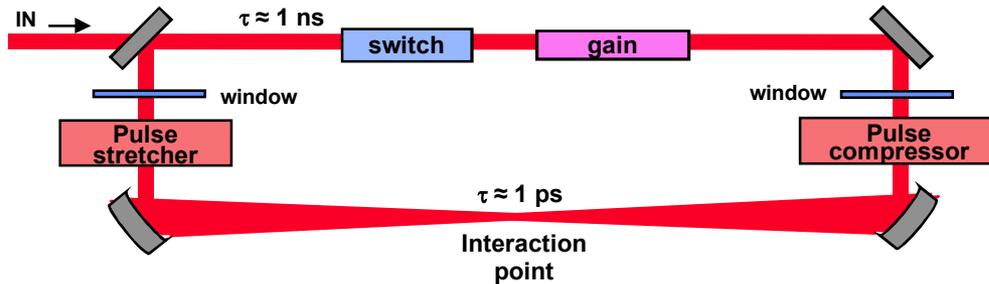
- 5 Hz x 2820 x 5 J ≈ 70 kW average power laser

Laser requirements depend on interaction configuration



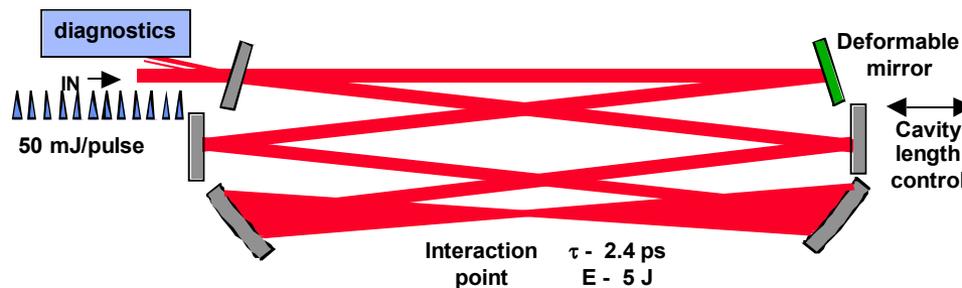
Brute force:

- High average power (~70 kW)



Recirculating cavity:

- 5-30x enhancement
- Gain replenishes loss each round trip
- Need very high efficiency optics (including gratings)



Resonant cavity:

- 100-300x enhancement
- Stringent requirements on pulse spatial/ temporal overlap (nm)

Short-pulse lasers



- **Chirped pulse amplification**
 - **Stretch pulses temporally before amplification to avoid nonlinear effects in optical system, then temporally compress after passing through most or all material**

- **State of the art**
 - **Jena fiber systems:**
 - **325 W average (8.2 μ J, 40 MHz, 375 fs, 30 μ m Yb-PCF core)¹**
 - **70 W average (0.7 mJ, 100 kHz, 800 fs, 80 μ m Yb-PCF core)²**
 - **Long-pulse:**
 - **42 W average (4.3 mJ, 9.6 kHz, 1 ns, 100 μ m Yb-PCF core)³**
 - **280 W average (150 μ J, 1.9 MHz, 3 ns, 41 mm Yb-LMA core)⁴**

[1] T. Eidam, et al., IEEE J. Sel. Top. Quant. Elect. 15, 187 (2009)

[2] F. Roser, et al., Opt. Lett. 32, 3495 (2007)

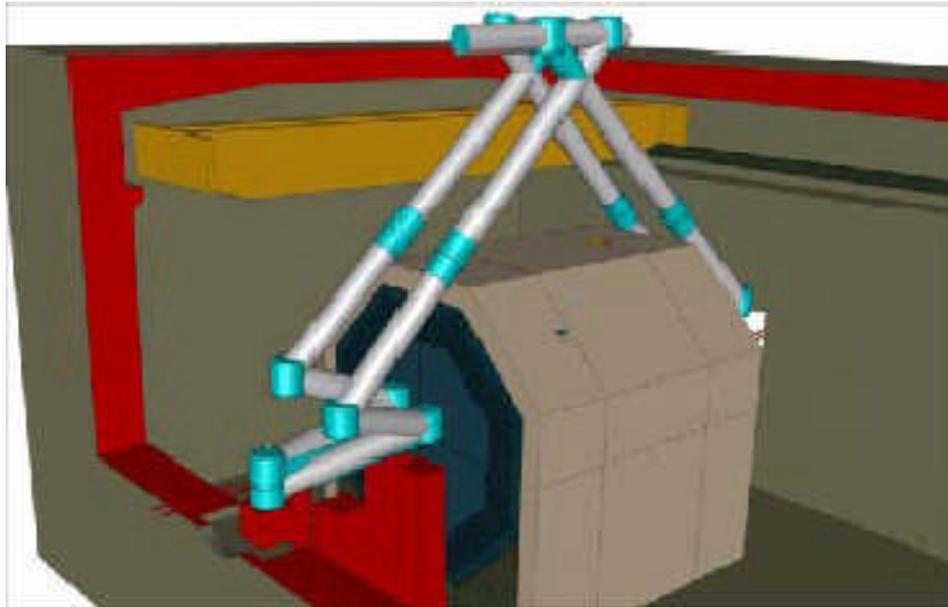
[3] C.D. Brooks and F. Di Teodoro, Appl. Phys. Lett. 89, 111119 (2006)

[4] W. Li, et al., Opt. Exp. 17, 10113 (2009)

Conceptual design for a resonant stacking cavity by DESY-Zeuthen and MBI*



- Design for L-band accelerator
 - 369 ns pulse spacing (111 m cavity length)



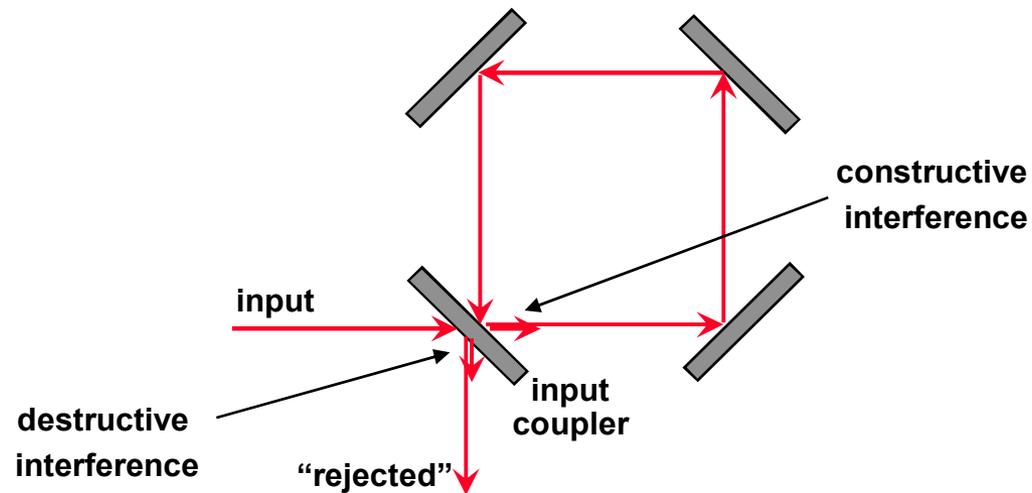
* I. Will, T. Quast, H. Redlin and W. Sander, "A Laser System For The TESLA Photon Collider Based On An External Ring Resonator", *Nucl. Instrum. Meth. A* **472** (2001) 79.

G. Klemz, K. Monig, I. Will, "Design study of an optical cavity for a future photon-collider at ILC", *Nucl. Instrum. Meth. A* **564** (2006) 212.

Resonant stacking cavity



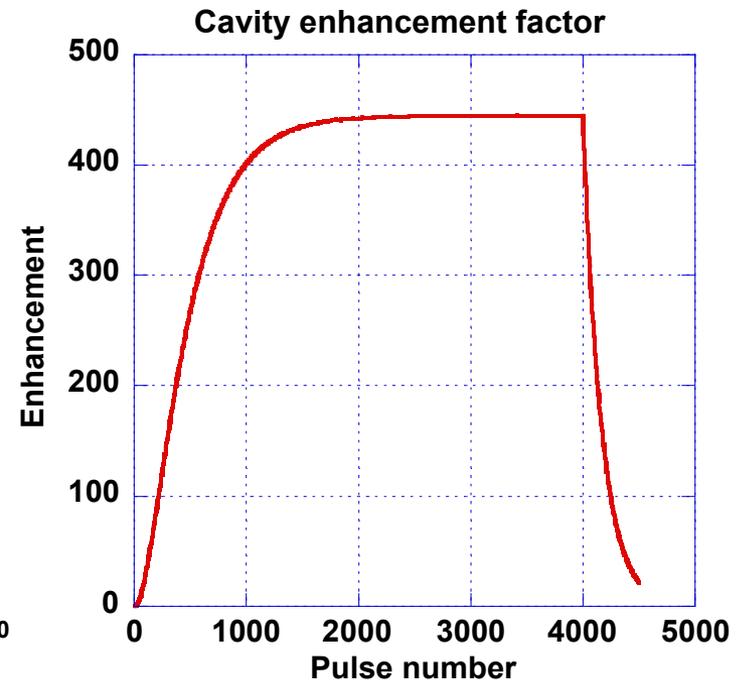
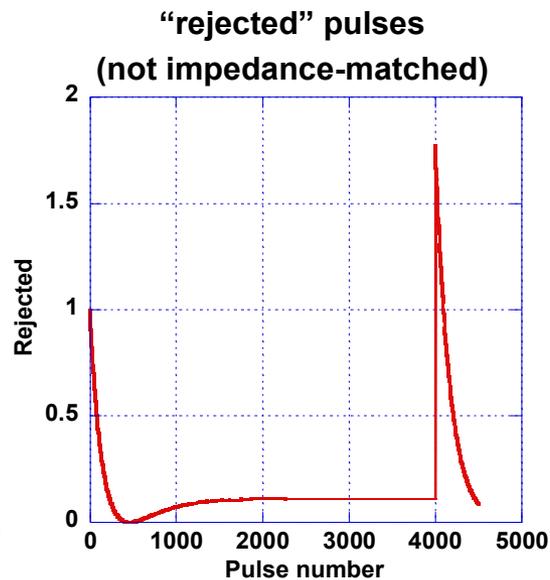
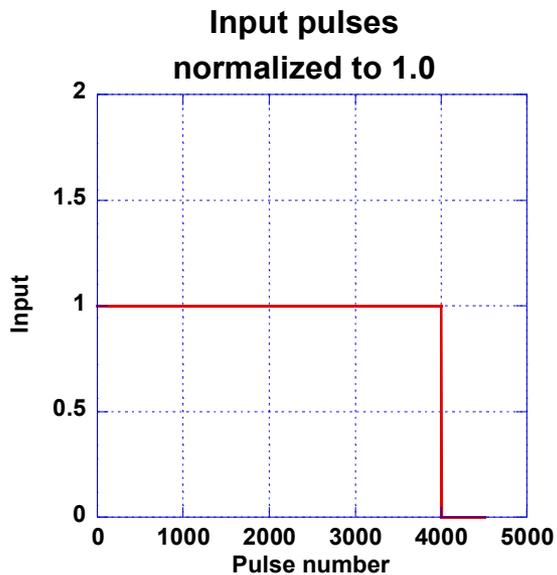
- Only $\sim 10^{-9}$ of laser energy used in each interaction
 - Reuse photons, replenish cavity losses
- Coherent addition of pulses in cavity requires extreme control of laser and cavity parameters



Resonant stacking cavity



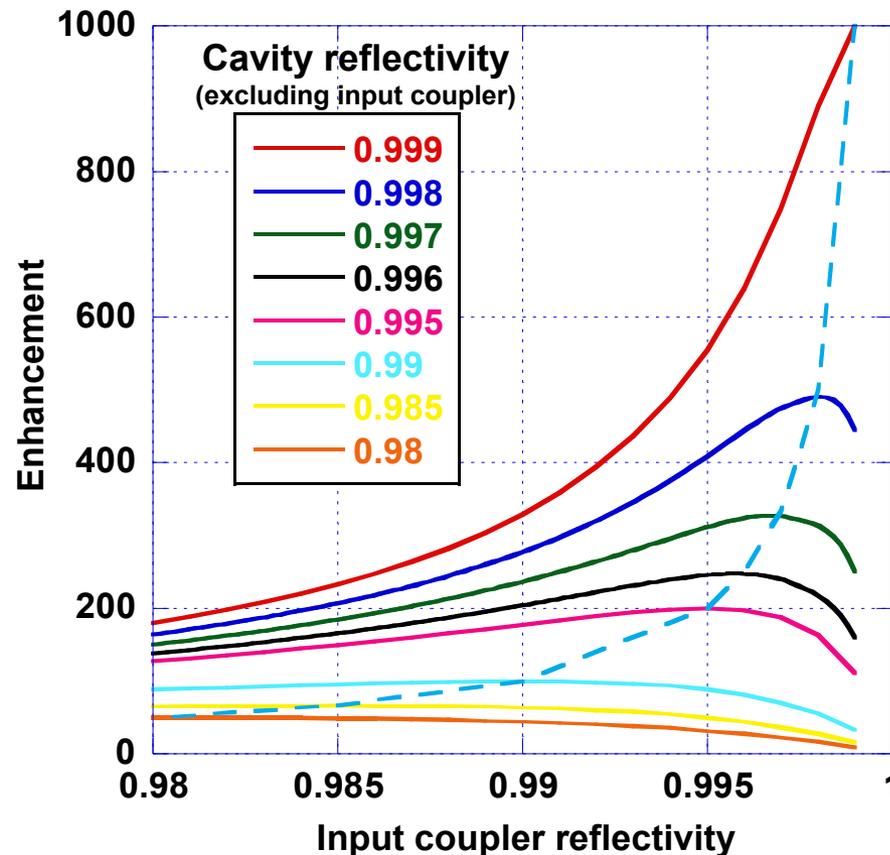
- Baseline case: input coupler $R=0.996$, cavity mirrors $R=0.998$



Enhancement as a function of mirror reflectivities



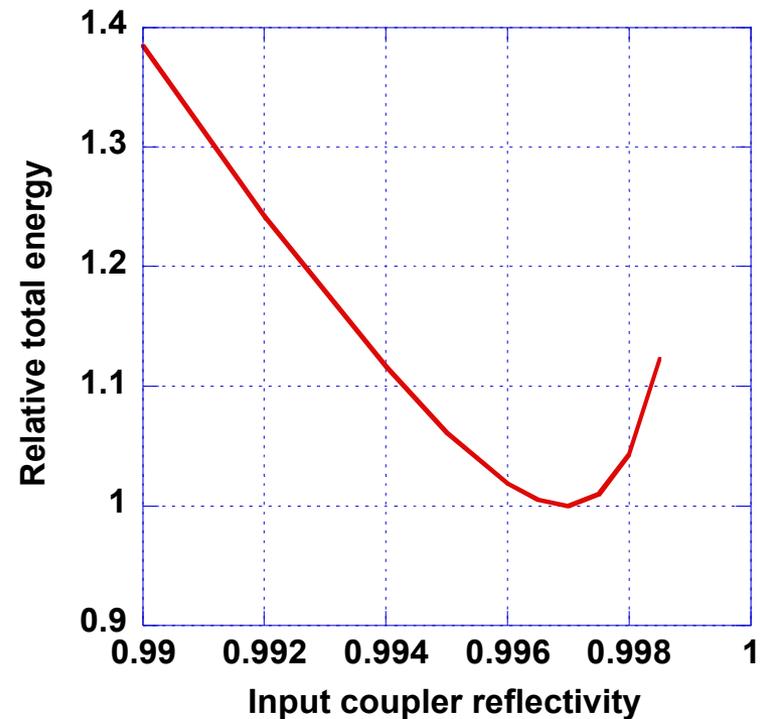
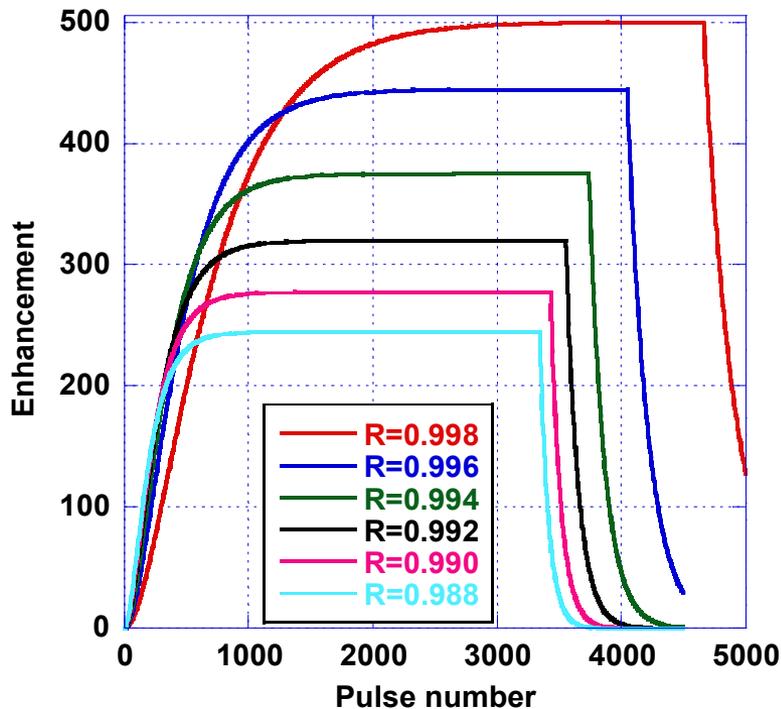
- Impedance-matched cavity (equal cavity and input coupler reflectivity) gives greatest enhancement for given cavity reflectivity
- For given input coupler, increasing cavity reflectivity increases enhancement



There is an optimum input coupler to minimize total energy



- Lower reflectivity input coupler gives faster cavity loading, but reduced enhancement
- Total energy \propto (# loading pulses to 95% + 2820)/enhancement



Resonant cavity enhancement puts stringent requirements on the laser and optics

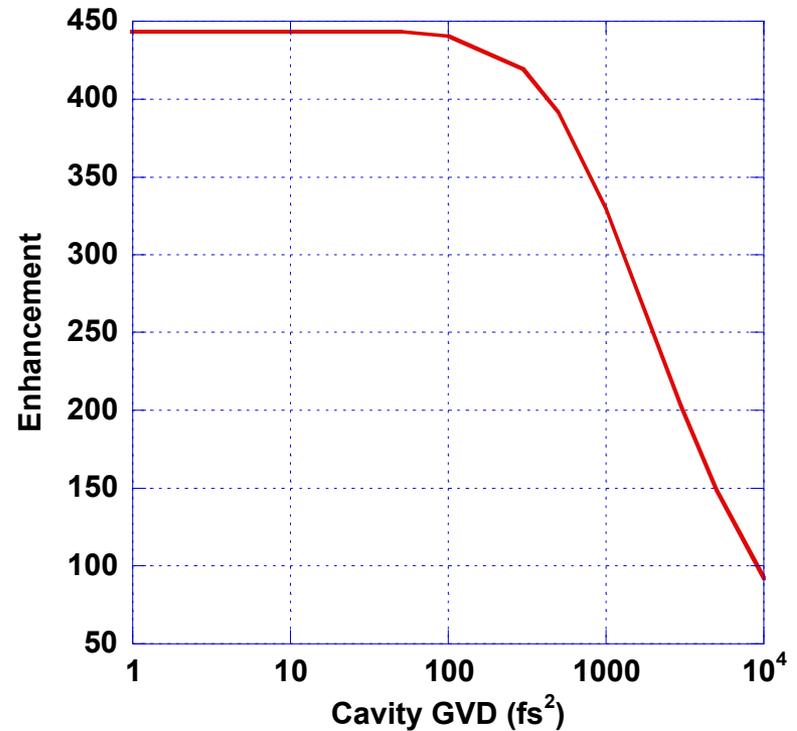
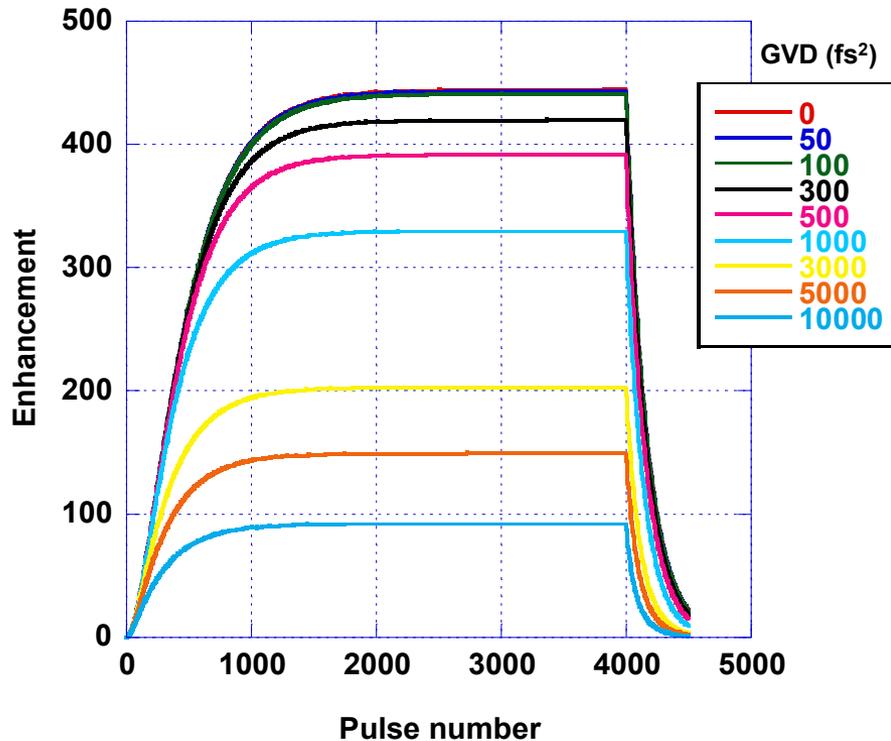


- Dispersion in resonant cavity
 - Phase noise
 - Cavity length/laser repetition frequency
 - Amplitude noise
 - Pointing through pulse compressor
-
- Coating damage due to scattered electrons and synchrotron radiation

Total cavity GVD should be less than 100 fs²



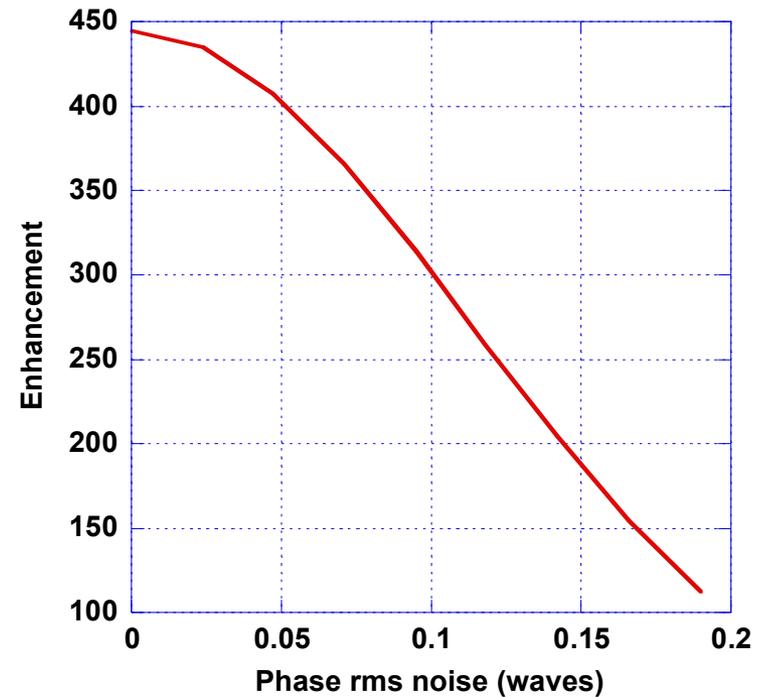
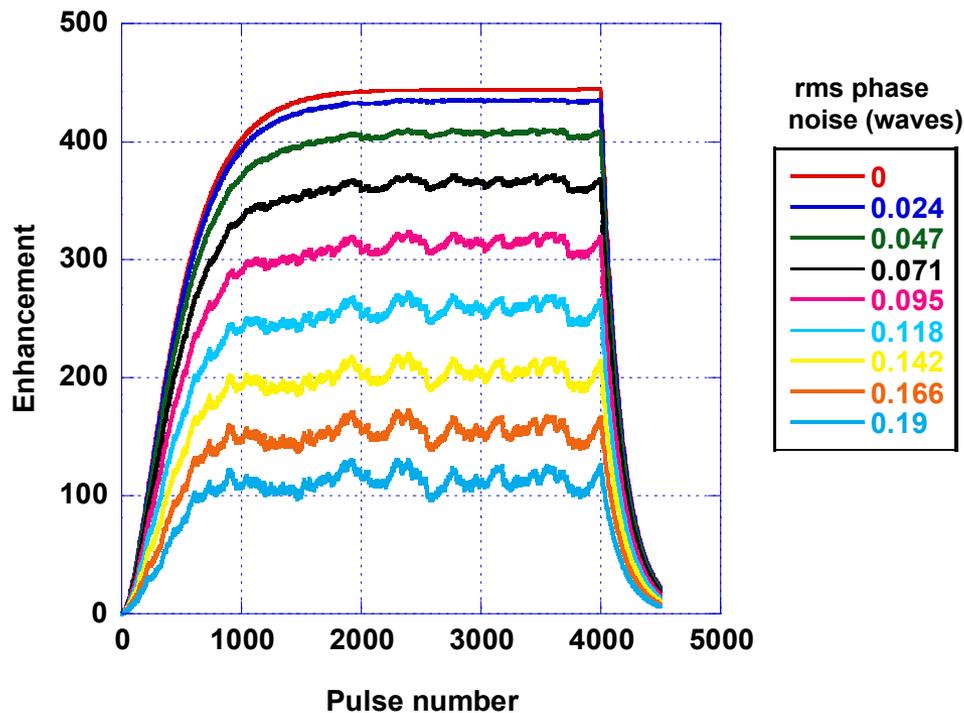
- Low-dispersion mirrors can be manufactured with $< 10 \text{ fs}^2$ GVD
 - Negative GVD mirrors also available



Phase noise



- 0.10 wave (650 mrad) achieved in CEP stabilized Ti:Sapphire system (1.4 mJ @ 1 kHz)*
- 0.03 wave (171 mrad) achieved with single amplifier (21 nJ, 75 MHz)**



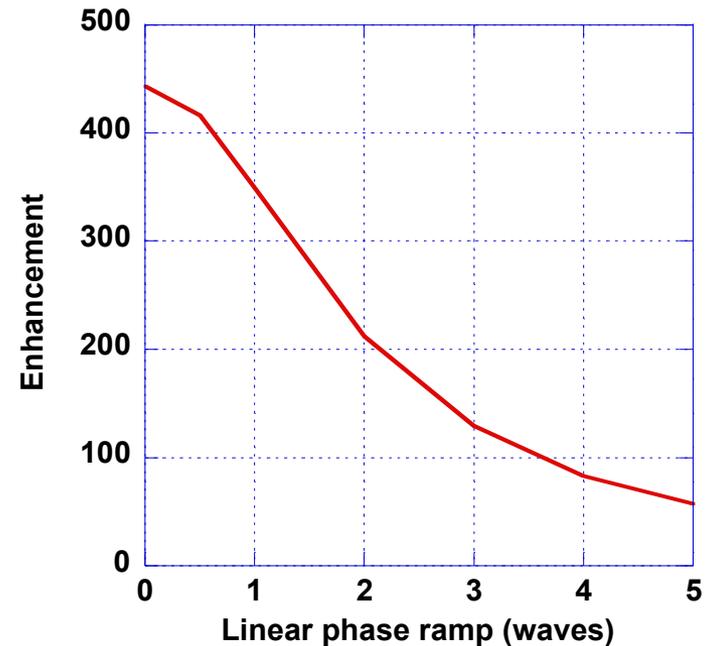
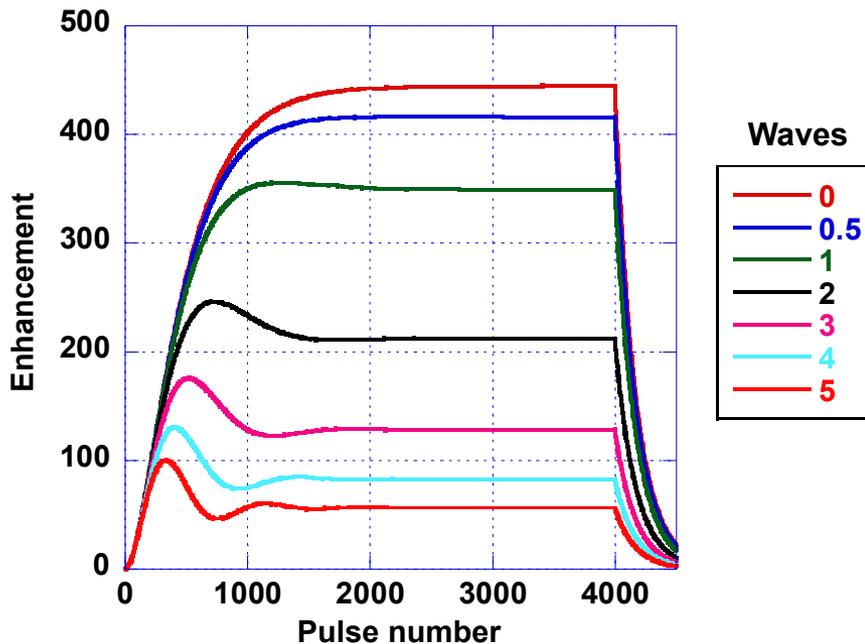
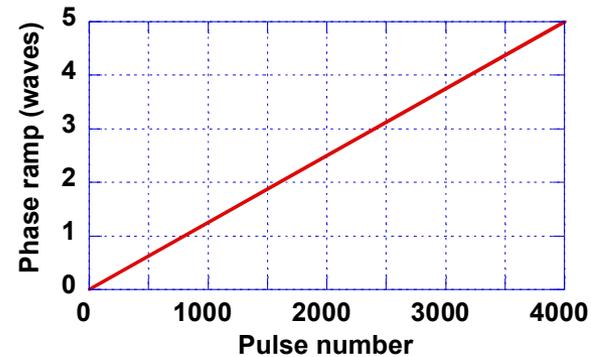
* E. Gagnon, et al., Opt. Lett. 31, 1866 (2006)

** A. Ozawa, et al., New J. Phys. 11, 083029 (2009)

Linear phase ramp through bunch



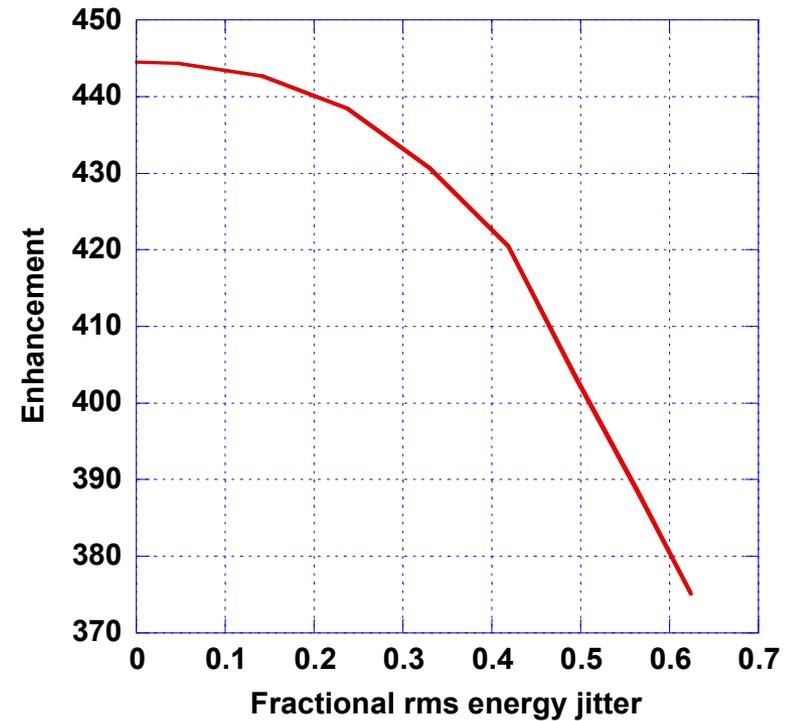
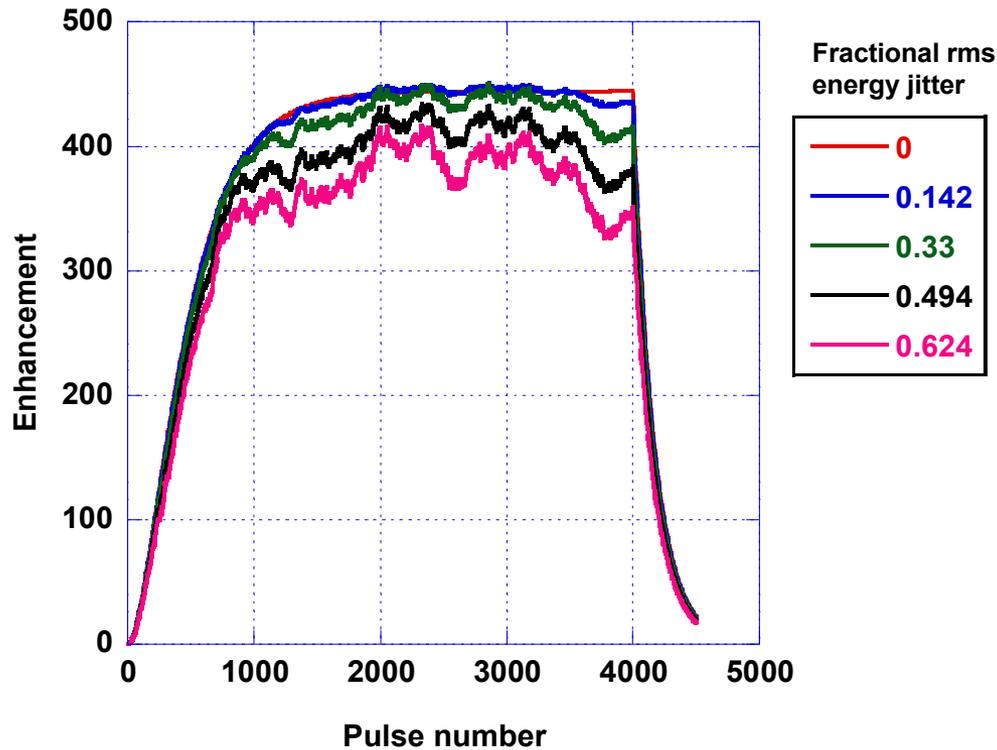
- Can relate to cavity length:
1 wave $\approx 1 \mu\text{m}$
1 wave/bunch $\approx 0.7 \text{ mm/s}$



Energy jitter



- No B-integral (phase) variation



The B-integral is a measure of nonlinear phase accumulation



Refractive index:

$$n(r, t) = n_o + \gamma I(r, t)$$

Phase:

$$\phi = \int k dz = \frac{2\pi}{\lambda} \int n(r, t) dz = \frac{2\pi n_o L}{\lambda} + B(r, t)$$

B-integral (nonlinear phase accumulation):

$$B(r, t) = \frac{2\pi}{\lambda} \int \gamma I(r, t) dz$$

Optical Kerr effect results in:

- Self-focusing and spatial beam collapse for $B > 3$
- Self-phase modulation and temporal distortions for $B > 1$

At 1 J/cm² and 1064 nm, $B=1$ for:

- 169 cm fused silica at 3 ns
- 0.56 mm fused silica at 1 ps

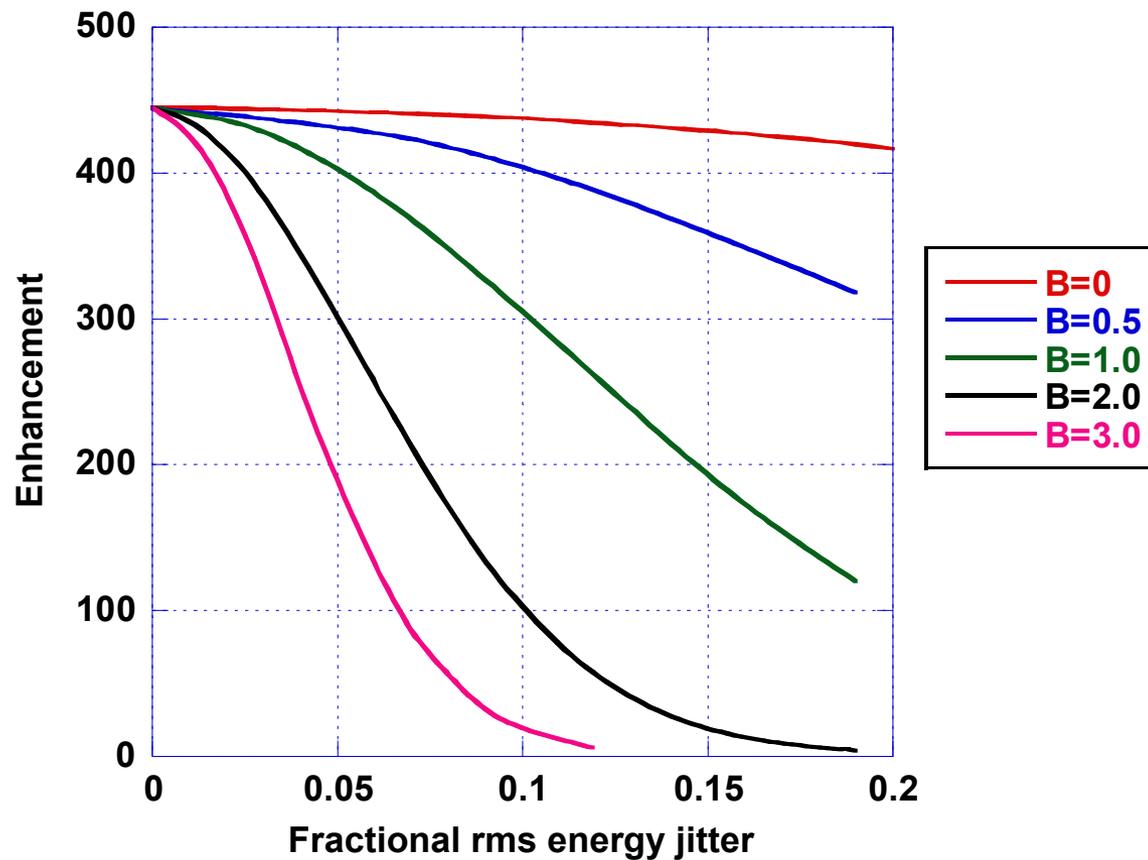
Fused silica:

$$\gamma = 3 \times 10^{-16} \text{ cm}^2/\text{W}$$

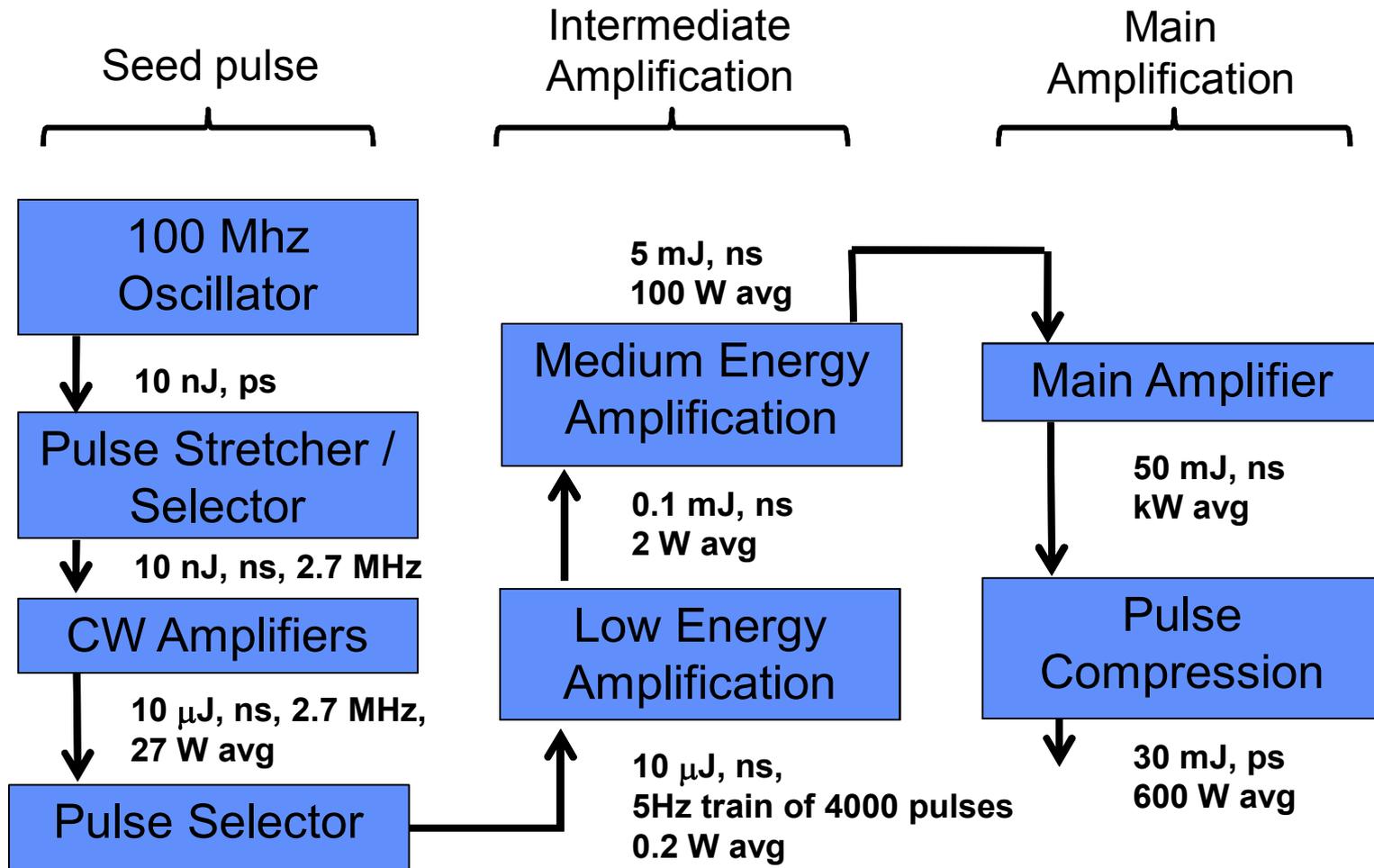
Energy jitter with B-integral



- Typical short-pulse lasers run with $B < 2$, but some fiber-laser designs have $B > 5$



Laser system concept



Pulse injection



100 MHz
Oscillator

10nJ, ps

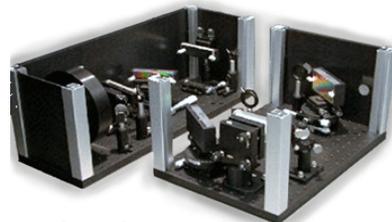
Pulse Stretcher /
Selector

100nJ, ns, 2.7 MHz

CW Amplifier

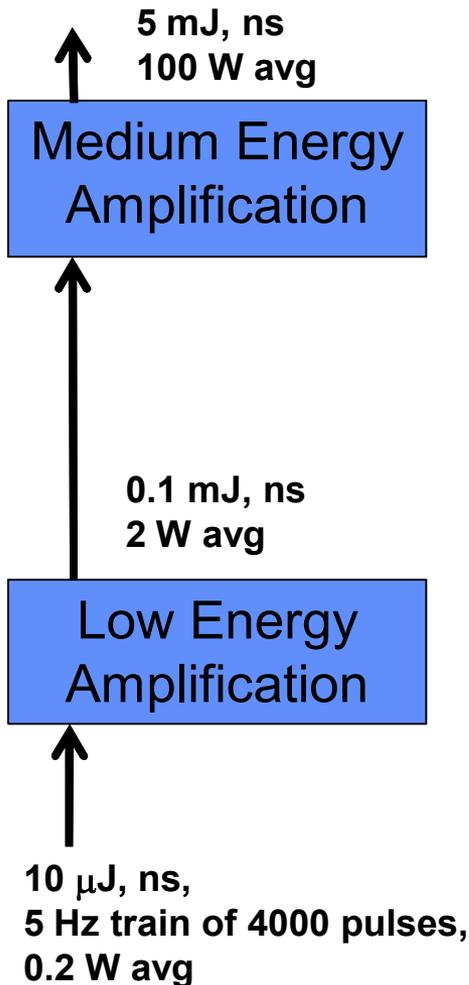
10 μ J, ns, 2.7 MHz
27 W avg

Pulse Selector



- “Off-the-shelf” technology
- Similar to lasers for ILC photogun
- Special photon collider requirements:
 - Need phase-locked oscillator at 1 μ m

Intermediate Amplification



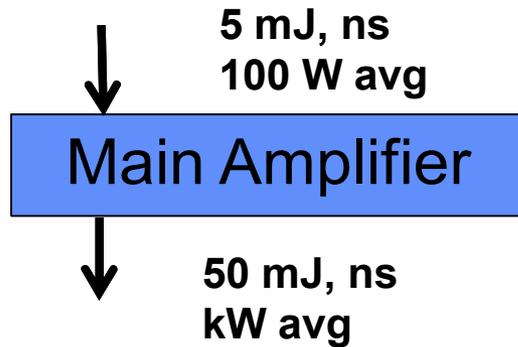
Cutting Edge Optronics' slab pumphead, the Whisper MiniSlab™



Cutting Edge Optronics RBA PowerPULSE

- “Off-the-shelf” technology exists to reach this power level
- At this level non-linear and thermal effects begin to be important

Main Amplifier

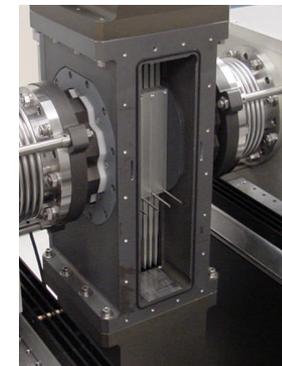


- Not commercially available
- Basic enabling technologies exist:
 - Diode pumping
 - Thermal management

Diode pumping
*Higher efficiency
and reliability,
Lower thermal
effects*



**Forced
cooling**
*Allows 10-Hz
operation*

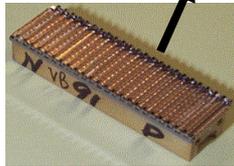
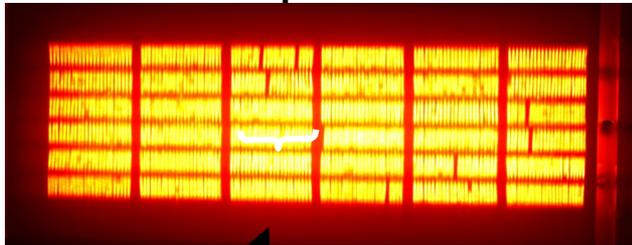


The Mercury laser at LLNL uses four 80 kW diode arrays for a total of 320 kW of peak diode power

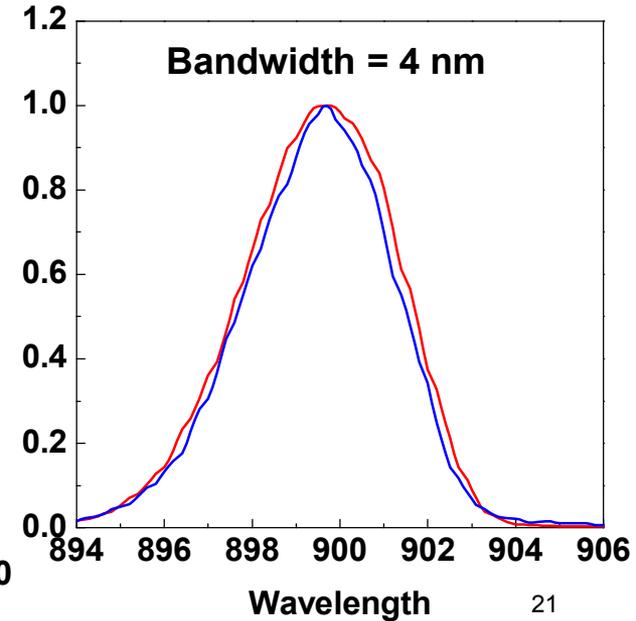
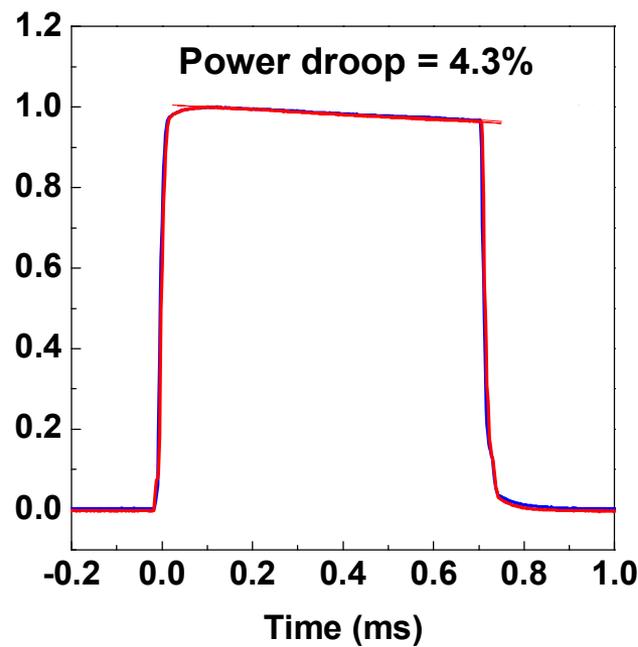
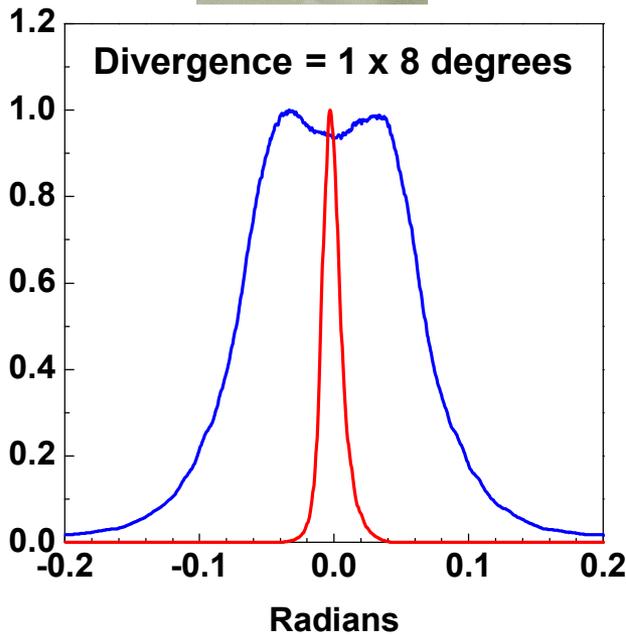


Operated at:

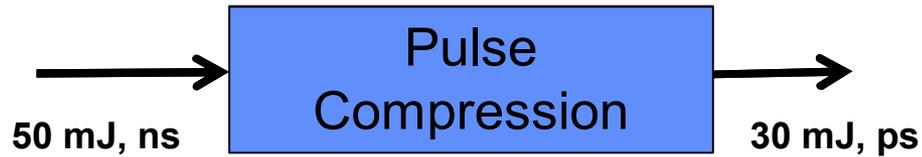
- 120 W/bar at 10 Hz
- 900 ms pulsewidth



tile with 23 diode bars



Pulse Compression

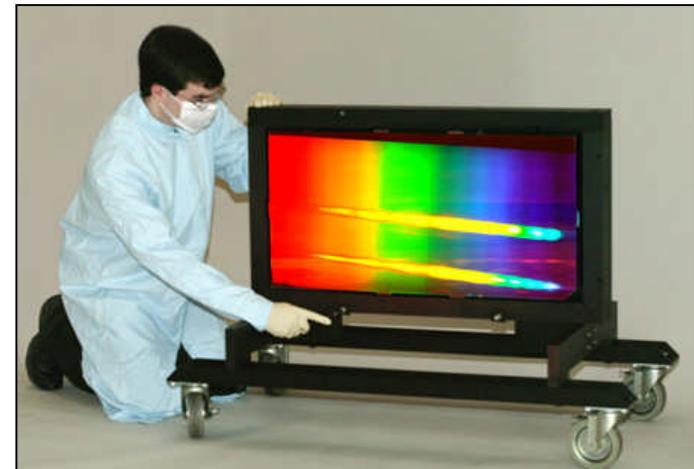


Vacuum compressor (Titan – LLNL)

- System will be in vacuum after compression
- Large gratings are needed to keep power levels low



World's largest dielectric gratings (LLNL)



Work to be done



- **Design of final amplifiers**
 - **Gain material**
 - **Pumping/extraction geometry**
 - **Minimize thermal effects**

- **Modeling of 2D sensitivities**
 - **Pointing jitter**
 - **Diffraction losses**
 - **Optical aberrations**

- **Conceptual design of laser system**

- **Conceptual design of control system**